

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE  
PATENT APPLICATION**

In re Application of:

Tran et al. Atty. Docket: TI-37297  
Serial No.: TBD Art Unit: TBD  
Filed: Herewith Examiner: TBD  
**For: AN IMPROVED CHEMICAL MECHANICAL POLISHING  
METHOD AND APPARATUS**

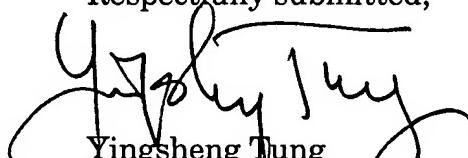
Commissioner for Patents  
P. O. Box 1450  
Alexandria, VA 22313-1450

**INFORMATION DISCLOSURE STATEMENT UNDER 37 CFR 1.97 & 1.98**

Sir:

Applicants wish to bring to the attention of the Patent and Trademark Office the information noted on the enclosed form PTO-1449. Pursuant to the new rule, no copies of these issued patents are being submitted. Please charge any necessary fees to the deposit account of Texas Instruments Incorporated, Account No. 20-0668. Charge any additional fee required or credit any overpayment to the same.

Respectfully submitted,



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FORM PTO-1449 (REV. 7-80)		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY. DOCKET NO. <b>TI-37297</b>		SERIAL NO. <b>TBD</b>	
<b>LIST OF DOCUMENTS CITED BY APPLICANT</b> <i>(Use several sheets if necessary)</i>							
				APPLICANT: <b>Tran et al.</b>			
				FILING DATE <b>Herewith</b>		GROUP <b>TBD</b>	
<b>U.S. PATENT DOCUMENTS</b>							
*EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE (IF APPROPRIATE)
		5,605,760	02/25/97	Roberts	428	409	08/21/95
		5,578,362	11/26/96	Reinhardt et al.	428	147	07/12/94
		5,489,233	02/06/96	Cook et al.	451	41	04/08/94
		5,257,478	11/02/93	Hyde et al.	451	287	01/31/92
		4,927,432	05/22/90	Budinger et al.	51	298	03/25/86
		4,841,680	06/27/89	Hoffstein et al.	451	42	09/20/88
		4,728,552	03/01/88	Jensen, Jr.	428	91	07/06/84
		5,900,164	05/04/99	Budinger et al.	216	88	10/20/97
<b>FOREIGN PATENT DOCUMENTS</b>							
		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SU B CL AS S	TRANSLATION
<b>OTHER DOCUMENTS</b> <i>(Including Author, Title, Date, Pertinent Pages, Etc.)</i>							
EXAMINER				DATE CONSIDERED			
<small>*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.</small>							